

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79367

Kazuya UENISHI, et al.
Appln. No.: 10/756,753

Allowed: December 12, 2005
Group Art Unit: 2881

Confirmation No.: 1538

Examiner: Bernard E. SOUW

Filed: January 14, 2004

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U.S. Patent No.: 7,078,687

For: THIN FILM ANALYZING METHOD

SUBMISSION OF ART

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

For the possible benefit of anyone subsequently evaluating the scope and/or validity of the above-identified patent, it is requested that the document that is listed below (copy enclosed) be placed in the U.S. Patent and Trademark Office's file wrapper of the above-identified U.S. patent:

Japanese Patent No. 61-137041

Japanese Patent No. 2001-33405

Japanese Patent No. 2002-184828

The above-listed documents were recently cited in a communication from a Foreign Patent Office dated May 17, 2006.

The undersigned has not reviewed the teachings of the above-listed document in detail and thus makes no representations concerning the relevancy or materiality of the above-listed document.

SUBMISSION OF ART
U.S. Patent Application No. 10/756,753
U.S. Patent No. 7,078,687

Attorney Docket No.: Q79367

This is not an Information Disclosure Statement and no response from the U.S. Patent
and Trademark Office is believed to be necessary, nor are any fees believed to be due.

Respectfully submitted,



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CUSTOMER NUMBER

Date: July 20, 2006